



DEP-REF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

2005 OCT 28 PM 4: 49

Mamoru NAKASUJI et al.

: Mail Stop: ACCOUNTING DIVISION  
REFUND BRANCH

Serial No. 10/651,105

Filed August 29, 2003

: Attorney Docket No. 2003\_1217A  
Confirmation No. 7747

ELECTRON BEAM SYSTEM

REQUEST FOR REFUND

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants request a refund of \$430 charged to Deposit Account No. 23-0975 on February 15, 2005 for a two month extension of time. Applicants assert the charge is incorrect.

The Office Action dated November 2, 2004 established a three month response period. The last date for a timely submission would be February 2, 2005. Applicants' Attorney submitted a Response to Restriction Requirement (copy enclosed) on Monday, January 31, 2005. This was obviously within the timely response period and so, no fee should have been incurred.

Kindly credit the refund of \$430 to the deposit account of undersigned, no. 23-0975. If there are any questions, please contact Kara Reade, Accounting Assistant, at (202) 721-8226.

Respectfully submitted,

Mamoru NAKASUJI et al.

By

Joseph M. Gorski  
Registration No. 46,500  
Attorney for Applicants

JMG/ker  
WENDEROTH, LIND & PONACK, L.L.P.  
2033 K Street, N.W., Suite 800  
Washington, D.C. 20006-1021  
Facsimile (202) 721-8250  
October 27, 2005

2003\_1217A

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 2005 OCT 28 PM 4:49

In re application of : Confirmation No. 7747  
Mamoru NAKASUJI et al. : Docket No. 2003-1217A  
Serial No. 10/651,105 : Group Art Unit 2881  
Filed August 29, 2003 : Examiner James P. Leybourne  
ELECTRON BEAM SYSTEM :

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

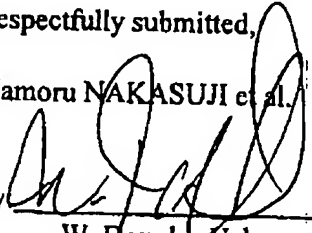
In response to the Restriction Requirement of November 2, 2004, Applicants hereby elect the invention of Group I, claims 1-26 and 54-62, drawn to a projection type transmission microscope, without traverse, for further prosecution.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Mamoru NAKASUJI et al.

By

  
W. Douglas Hahn  
Registration No. 44,142  
Attorney for Applicants

WDH/gtg  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
January 31, 2005

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THW

Fee Only

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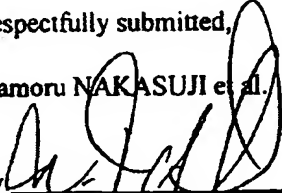
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W. Douglas Hahn  
Registration No. 44,142  
Attorney for Applicants

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01 FC:1252 430.00 CR

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January 31, 2005

Adjustment Date: 12/06/2005 SDIRETA1  
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